

PATENT

-1-

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

Louis N. Koppel et al.

Application No.: 10/643,348

Filed: August 19, 2003

For: CALIBRATION AND ALIGNMENT  
OF X-RAY REFLECTOMETRIC  
SYSTEMS

Group Art Unit: 2882

Examiner: I. Kiknadze

**CHANGE OF ATTORNEY OR AGENT'S  
ADDRESS IN APPLICATION  
(37 CFR 1.8(a))**

353 Sacramento Street, Suite 2200  
San Francisco, CA 94111  
(415) 772-4900

M/S ISSUE FEE  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

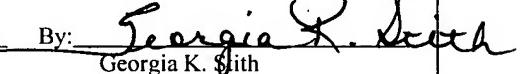
**CERTIFICATE OF MAILING**

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope, addressed to: Commissioner for Patents, P.O. Box 1450 Alexandria, VA 22313-1450 on June 4, 2004.

STALLMAN & POLLOCK LLP

Dated: 06/04/2004

By:

  
Georgia K. Smith

Sir:

Please send all correspondence for this application to:

STALLMAN & POLLOCK LLP  
Attn: Michael A. Stallman  
353 Sacramento Street, Suite 2200  
San Francisco, CA 94111  
Customer No.: 28584

Please direct all telephone calls to:

Michael A. Stallman  
Telephone: (415) 772-4900  
Facsimile: (415) 398-2890

Respectfully submitted,

STALLMAN & POLLOCK LLP

Dated: June 4, 2004

By:   
Stephen M. Everett  
Reg. No. 30,050

Attorneys for Applicant(s)

Atty Docket No.: TWI-11720